



Title: APPARATUS AND METHOD FOR DEPOSITING AND PLANARIZING
THIN FILMS OF SEMICONDUCTOR WAFERS
Inventor(s): Ravkin et al.
App. No: 10/607,611 Docket No: LAM2P428

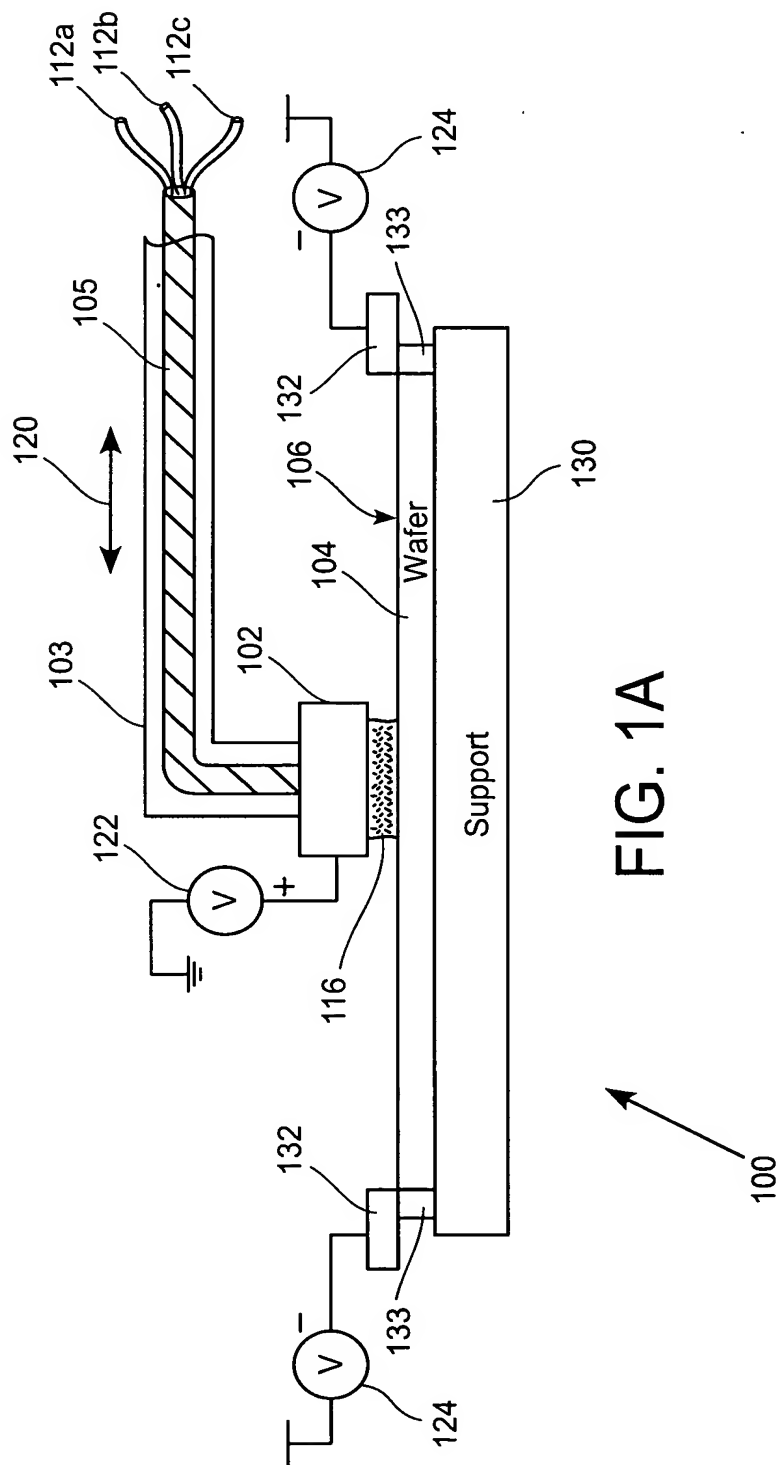
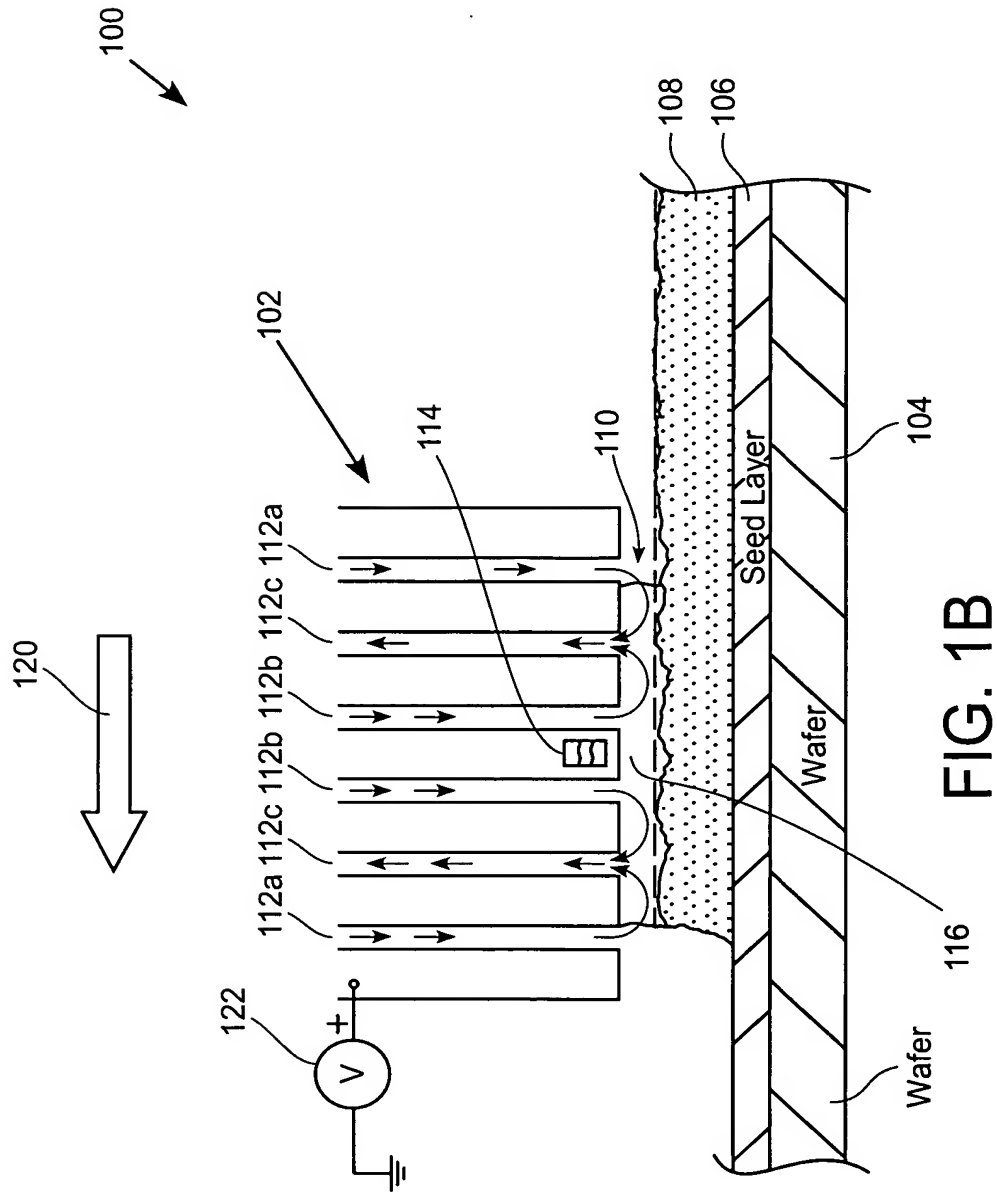


FIG. 1A



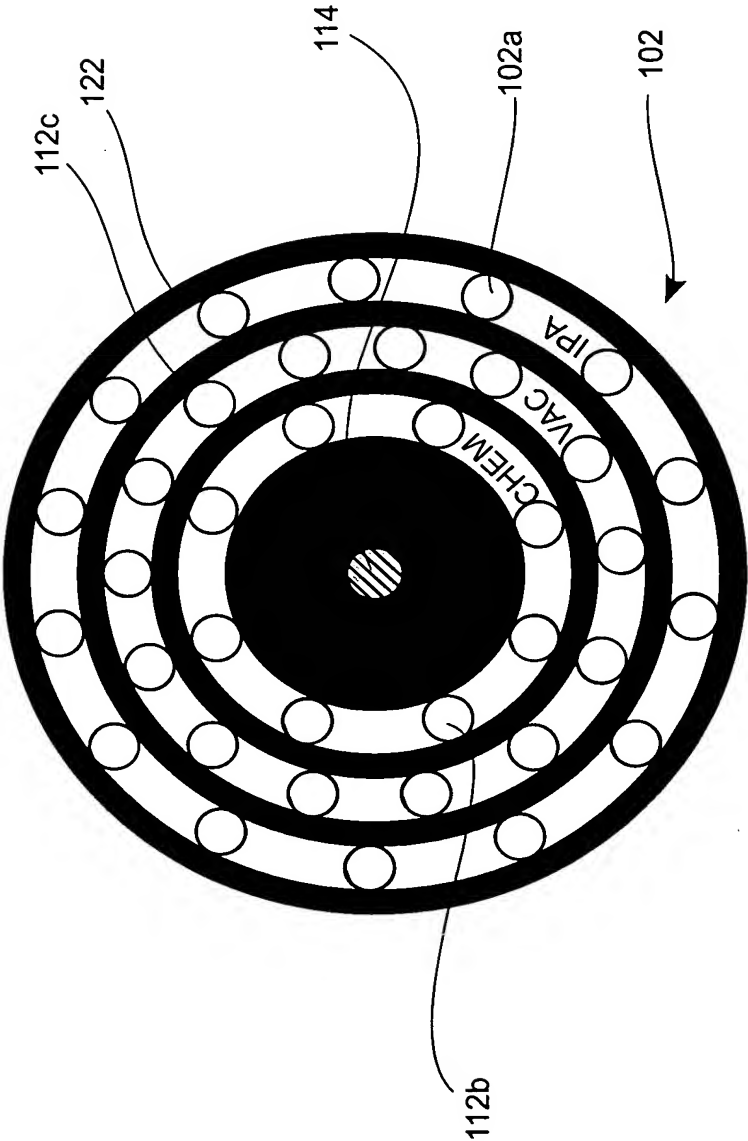


FIG. 1C

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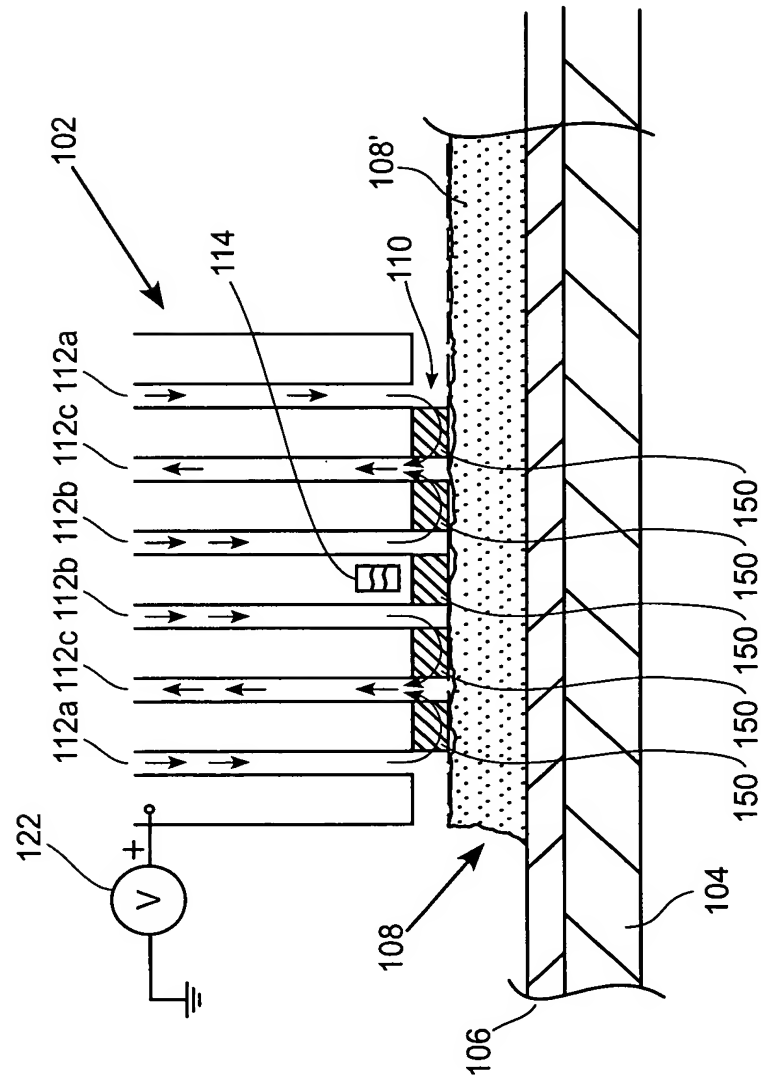


FIG. 1D

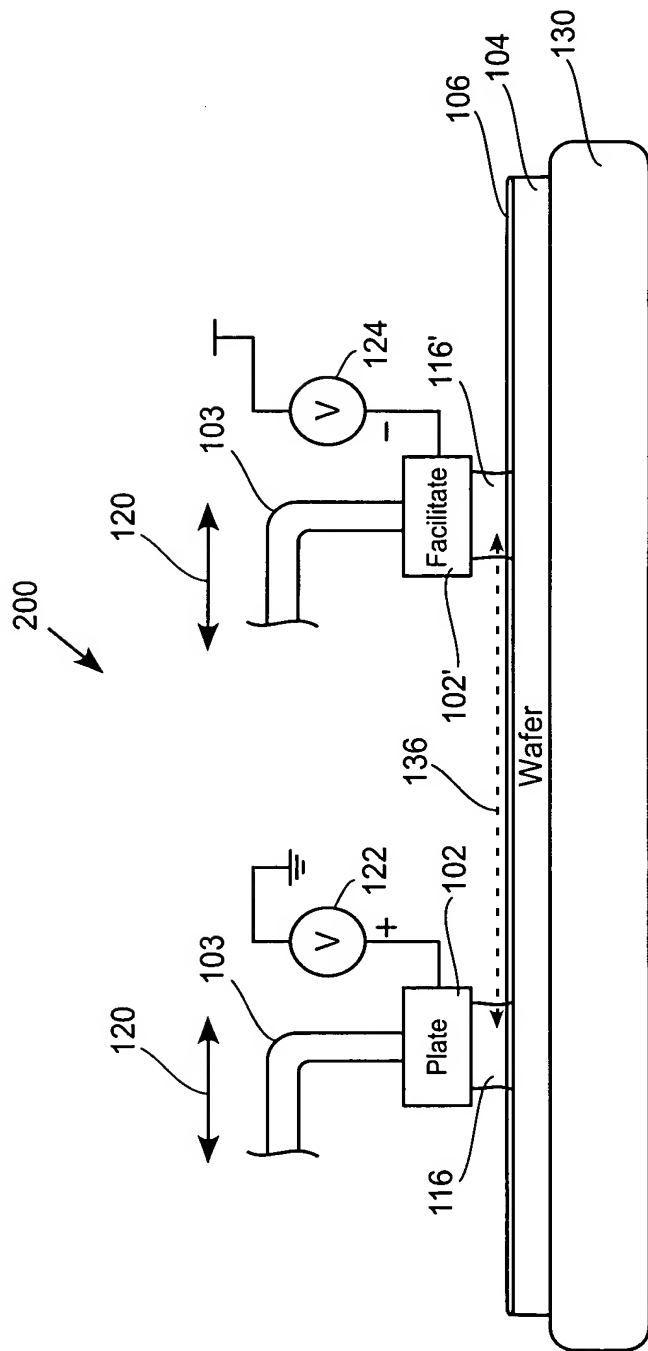


FIG. 2A

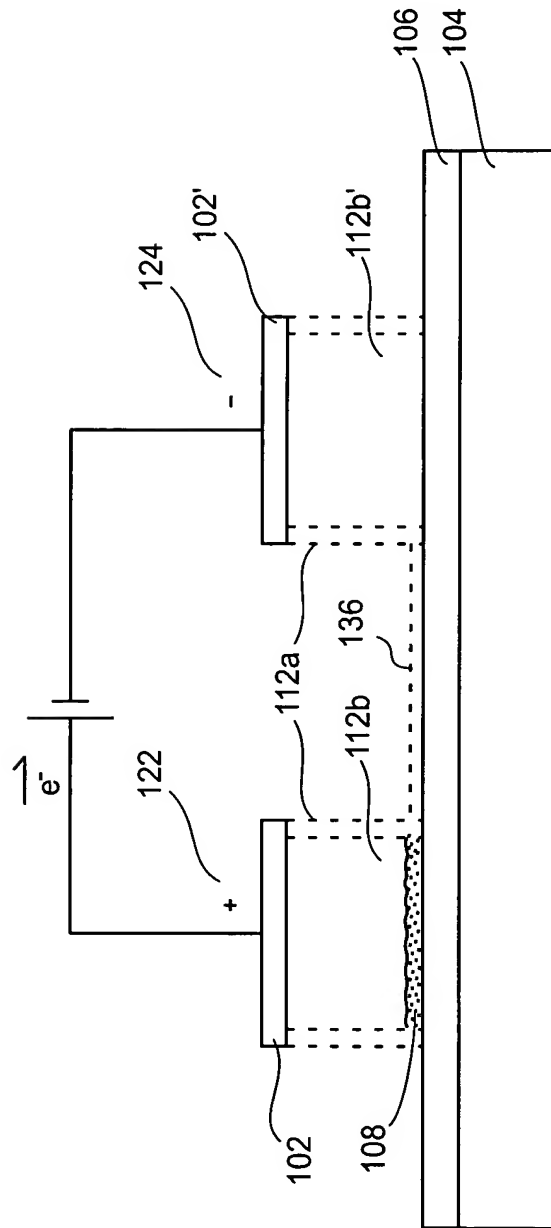
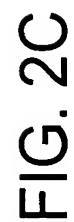


FIG. 2B



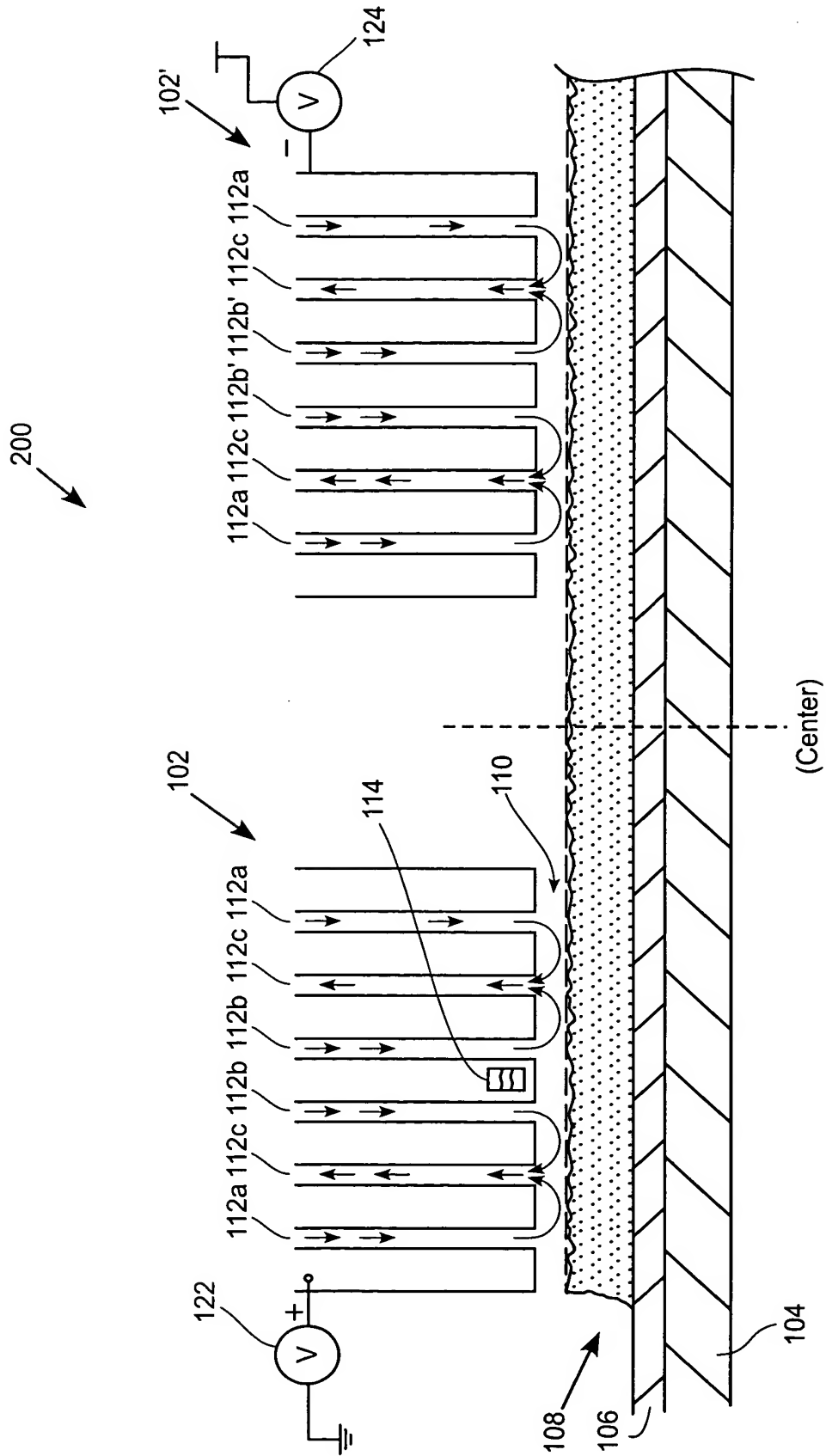


FIG. 2D

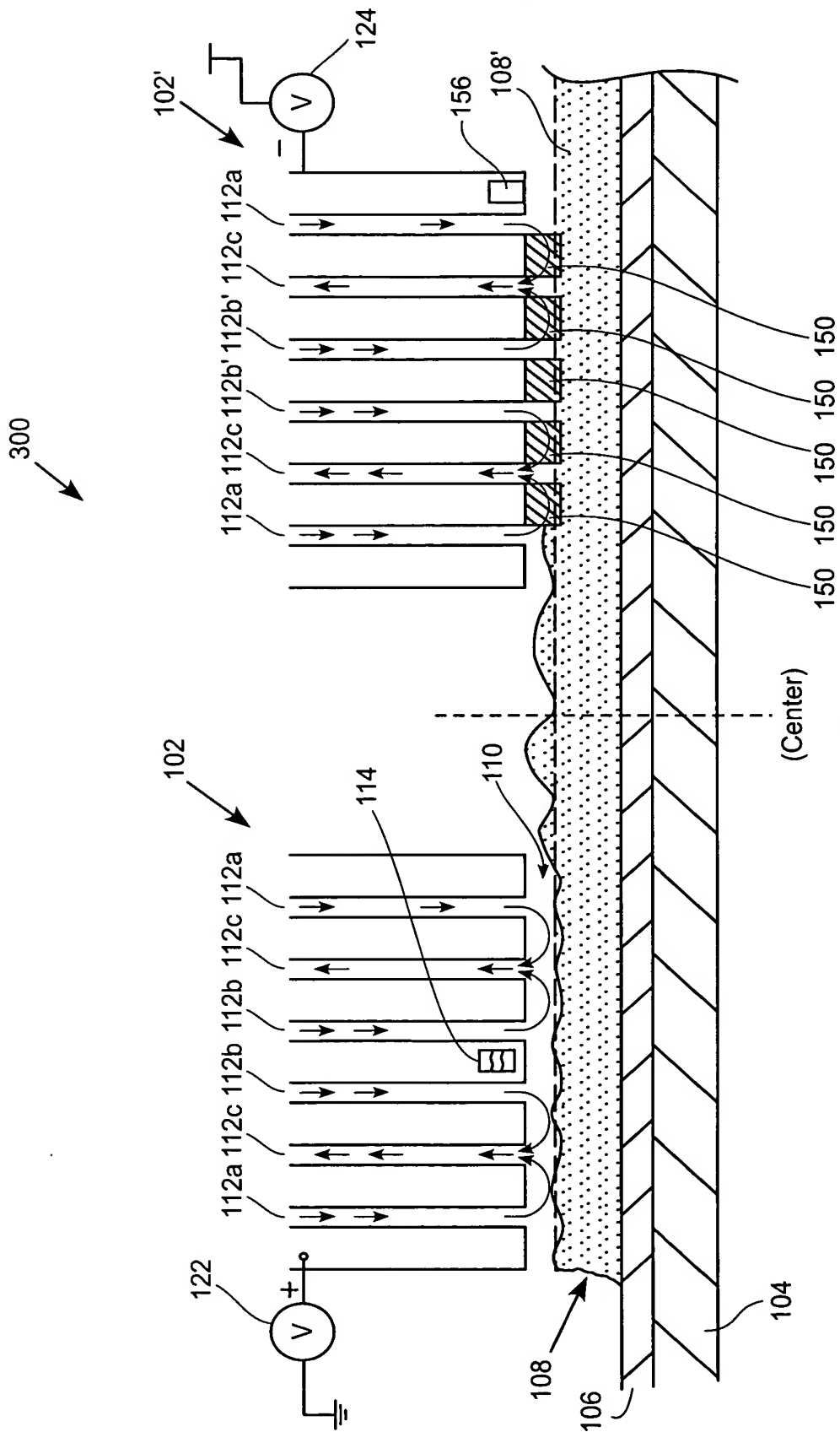


FIG. 3

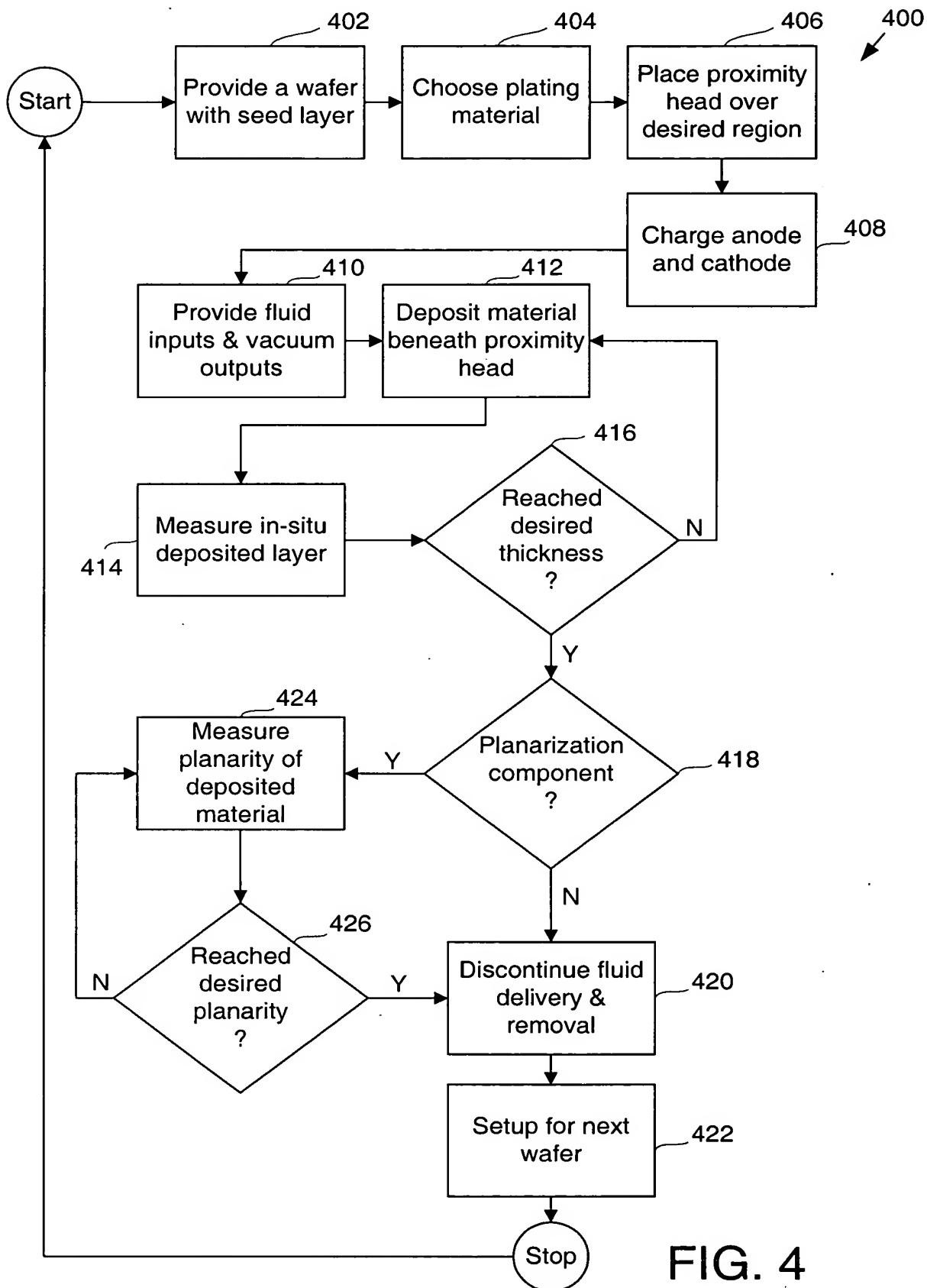


FIG. 4